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Scut 81

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10004995	12/05/2001	429		1745	<i>Leising</i>

**APPLICANTS: Leising Randolph; Takeuchi Esther;

Carito Lino

**CONTINUING DATA VERIFIED:

THIS APPLN CLAIMS BENEFIT OF 60/254,918 12/12/2000

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** FOREIGN APPLICATIONS VERIFIED:

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	ATTORNEY DOCKET NO
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no			04645.0844
35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no			
Verified and Acknowledged Examiners's initials			
TITLE : Preparation of epsilon-phase vanadium oxide from gamma-phase SVO starting material			

U.S. DEPT. OF COMMERCE / PAT & TM-PTO-435 (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drawg.	Figs. Drawg.
		Print Fig.	
Assistant Examiner		Primary Examiner	
PREPARED FOR ISSUE		Application Examiner	
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